

**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MARK B. FUSELIER  
DERICK J. WRISTERS  
ANDY C. WEI

Confirmation No.: 9406

Group Art Unit: 2811

Serial No.: 10/821,230

Examiner: Ori Nadav

Filed: April 8, 2004

Att'y Docket: 2000.092182/TT5077D

For: SEMICONDUCTOR DEVICE FORMED  
OVER A MULTIPLE THICKNESS  
BURIED OXIDE LAYER, AND  
METHODS OF MAKING SAME

Customer No.: 23720

**PRELIMINARY AMENDMENT; RESPONSE  
TO FINAL OFFICE ACTION DATED JUNE 19, 2007**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-captioned patent application as requested herein.

The Director is authorized to deduct any fees required under 37 C.F.R. §§ 1.16 to 1.21 from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.092182.